

Notice of References Cited	Application/Control No. 10/616,344	Applicant(s)/Patent Under Reexamination IWAMURA, RYUICHI	
	Examiner Salvador E. Rivas	Art Unit 2616	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0184427 A1	09-2004	Lynch et al.	370/342
*	B	US-6,064,662	05-2000	Gitlin et al.	370/330
*	C	US-2003/0039317 A1	02-2003	Taylor et al.	375/295
*	D	US-6,356,555 B1	03-2002	Rakib et al.	370/441
*	E	US-7,212,564 B2	05-2007	Parizhsky et al.	375/144
*	F	US-6,442,129 B1	08-2002	Yonge et al.	370/204
*	G	US-6,826,160 B1	11-2004	Wang et al.	370/329
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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